



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : John E. Peterson, et al.      Docket No. : IL-10786  
Serial No. : 09/916,847      Art Unit :  
Filed : 7/26/2001      Examiner :  
For : Reduction of Damage Initiation Density in Fused Silica Optics  
via UV Laser Conditioning

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Forwarded herewith is an Information Disclosure Statement, Form-1449, in the above-identified application. Copies of the cited references are enclosed: 1 U.S. Patent Document. This item of information was first cited in a PCT International Search Report dated November 12, 2002 in a counterpart foreign application which is not more than three months prior to the filing of this Information Disclosure Statement.

The above-mentioned disclosures, which are not admitted as prior art, are identified on the enclosed Form 1449.

Respectfully submitted,

Dated: December 5, 2002

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Enclosures: As noted above